

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :

Yoichi MORI et al. :

Serial No. NEW :

Attn: Application Branch

Filed November 17, 2000 :

Attorney Docket No. 2000-1578A

METHOD AND APPARATUS FOR  
TREATING A WASTE GAS CONTAINING  
FLUORINE-CONTAINING COMPOUNDS :

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P.C.  
4-10-01  
THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEE FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975.

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

Prior to examination of the instant application, please enter and consider the following amendments and remarks as follows:

In The Claims:

Kindly amend claim 7 as follows:

Claim 7. line 1, delete "or 6".

Kindly add the following new claim 8:

A' -- 8. The apparatus according to claim 6, which has not only an air ejector capable of adjusting the pressure in the apparatus through which the waste gas passes but also an FT-IR analyzer for controlling the emission density of the treated gas.--